



*Handwritten signature and date: 5/2/05*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9134**  
Shoriki NARITA et al. : Docket No. 2001\_1718A  
Serial No. 09/988,704 : Group Art Unit 2625  
Filed November 20, 2001 : Examiner Sheela Chawan

METHOD AND APPARATUS FOR CORRECTING  
INCLINATION OF IC ON SEMICONDUCTOR WAFER

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents  
P.O. Box 1450  
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Sir:

Attached hereto is a check in the amount of \$120.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time ..... \$120.00

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*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Shoriki NARITA et al.

By

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